



P/1250-214

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Masayoshi SHIGA, et al. Date: October 20, 2003
Serial No.: 09/942,153 Group Art Unit: 2812
Filed: August 29, 2001 Examiner: Karla A. Moore
For: SUBSTRATE PROCESSING APPARATUS, SUBSTRATE INSPECTION
METHOD AND SUBSTRATE PROCESSING SYSTEM

RECEIVED

OCT 23 2003

TC 1700

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION AND FEE FOR AUTOMATIC EXTENSION OF TIME
UNDER 37 CFR 1.17, 1.136(a) AND 35 USC 41(a)8

Sir:

Applicants hereby petition the Asst. Commissioner for Patents to extend the time for filing a response to the outstanding Office Action by two months. Enclosed is our check No. 12985 which includes the amount of \$110.00 for the petition fee in accordance with 37 CFR 1.17 computed as:

Response within first month not small entity (\$110)

You are authorized to charge to our Deposit Account No. 15-0700 any additional amounts owing.

If this petition is inadequate to avoid abandonment, the Assistant Commissioner for Patents is petitioned, under 37 C.F.R. §1.136(a), to extend the time by the number of months which will avoid abandonment under 37 C.F.R. §1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail to Addressee (mail label #EV342534361US) in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, Alexandria, VA 22313-1450, on October 20, 2003

DOROTHY JENKINS

Name of Person Mailing Correspondence

October 20, 2003

Date of Signature

Respectfully submitted,

Max Moskowitz

Registration No.: 30,576

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

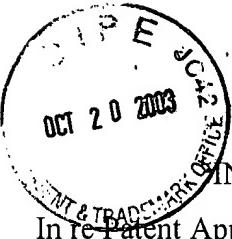
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PRELIMINARY AMENDMENT/SUBMISSION

Sir:

This is a response to the Office Action mailed in the above-identified application.

Reconsideration of the application is respectfully requested.

FEE CALCULATION

Any additional fee required has been calculated as follows:

If checked, "Small Entity" status is claimed.

NO. CLAIMS AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	EXTRA PRESENT	RATE	ADDIT. FEE
TOTAL 12	MINUS 20	* = 0	X (\$9 SE or \$18)	\$0
INDEP. 4	MINUS 5	** = 0	X (\$43 SE or \$86)	\$0
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM			X (\$145 SE or \$290)	\$0

* not less than 20 ** not less than 3

TOTAL \$ 0

If any additional payment is required, a check which includes the calculated fee of \$ _____
(OFGS Check No. _____) is attached.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.